

COPY

PATENT
465-608P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Dong K. SOHN et al.
Appl. No.: NEW Group: Unknown
Filed: December 15, 1999 Examiner: UNKNOWN
For: METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE

L E T T E R

Assistant Commissioner for Patents
Washington, DC 20231

December 15, 1999

Sir:

Under the provisions of 35 U.S.C. § 119 and 37 C.F.R. § 1.55(a), the applicant(s) hereby claim(s) the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
KOREA	1999/22580	June 16, 1999

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 

Terry L. Clark, #32,644

TLC/HNS:ewd
465-608P

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachment

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Dong K. SOHN et al
Filed: 12-15-99
Docket: 465-608P
BSKB
(703) 205-8000

대한민국 특허청
KOREAN INDUSTRIAL
PROPERTY OFFICE

별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Industrial
Property Office.

출원번호 : 1999년 특허출원 제22580호
Application Number

출원년월일 : 1999년 6월 16일
Date of Application

출원인 : 엘지반도체 주식회사
Applicant(s)



1999년 7월 22일

특허청
COMMISSIONER

